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OLIFF & BERRIDGE, PLC

ATTORNEYS AT LAW

Application Data Sheet

Applicant Information

Applicant Authority type:: Inventor

Primary Citizenship Country:: Japan

Status:: Full Capacity

Given Name:: Masakazu

Family Name:: SATO

City of Residence:: Fukushima

Country of Residence:: Japan

Applicant Authority Type:: Inventor

Primary Citizenship Country:: Japan

Status:: Full Capacity

Given Name:: Masato

Family Name:: ONISHI

City of Residence:: Fukushima

Country of Residence:: Japan

Correspondence Information

Correspondence Customer Number:: 25944

Application Information

Application Type:: National Phase

Subject Matter:: Utility

CD-ROM or CD-R:: None

Title:: METHOD OF EVALUATING SHAPE OF

SEMICONDUCTOR WAFER AND

APPARATUS FOR EVALUATING SHAPE

OF SEMICONDUCTOR WAFER

Attorney Docket Number:: 122035

Total Drawing Sheets:: 8

Small Entity:: No

Representative Information

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Domestic Priority Information			
Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application is a	National Stage of	PCT/JP03/07320	06/10/2003
Foreign Priority Information			<u> </u>
Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2002-173268	06/13/2002	Yes
Assignee Information			1
Assignee Name::		SHIN-ETSU HANDOTAI CO., LTD.	
Street of mailing address::		4-2, Marunouchi 1-chome,	
City of mailing address::		Chiyoda-ku,	
State or Province of mailing address::		Tokyo,	
Country of mailing address::		Japan	

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